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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Application Number	10/044,899
				Filing Date	01-09-2002
				First Named Inventor	Nicholas L. Abbott
				Group Art Unit	1639
				Examiner Name	Lundgren, Jeffrey S.
Sheet	1	of	1	Attorney Docket Number	061818-5002-US04

U.S. PATENT DOCUMENTS				
Exr Initials	U.S. Patent Document		Name of Inventor or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
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FOREIGN PATENT DOCUMENTS						
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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS				
Exr Initials	Include Name of Author (in CAPITAL LETTERS), title of the article (where appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published			T ₁
	Motohiro, T.; Taga, Y. Sputter-Deposited SiO _x Films for Liquid Crystal Alignment, <i>Thin Solid Films</i> , 1990 , 185 (1), pp 137-144.			
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DB2/22240611.2

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² Applicant is to place a check mark here if English language Translation is attached.

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